



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.022438.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoshinori MIWA

Application No.: 09/987,568

Filed: November 15, 2001

For: EXPOSURE APPARATUS AND EXPOSURE
METHOD

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

)
: Examiner: H. Nguyen
)
: Group Art Unit: 2851
)
:
:
) August 7, 2003
:

#9/BTH
Sub. Spec. (N/E)
8-13-03
JFR

TECHNOLOGY CENTER 2800

AUG 12 2003

RECEIVED

AMENDMENT AFTER FINAL REJECTION AND LETTER
FORWARDING SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated May 7, 2003, please amend the above-

identified application as follows:

Please do not
amend

8/17/03
HN